

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition
1	IS&R	L1	0	("(ion\$with(eV or keV or "electronvolts")) same(dopant or implant\$3 or implant\$5)").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:12		
2	BRS	L2	16766	(ions with(eV or keV or "electronvolts")) same (dopant or implant\$3 or implant\$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:15		
3	BRS	L3	3437	(ions with (eV or keV or "electronvolts")) same dopant	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:15		
4	BRS	L4	637	(ions with (eV or keV or "electronvolts")) same dopant same etch\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:17		
5	BRS	L5	4484	4 and @pd<="20030213"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:17		

	Errors
1	
2	
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	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition
6	BRS	L6	190	(ions with (eV or keV or "electronvolts")) same dopant same etch\$3 same (known or conventional)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:17		
7	BRS	L7	1366	6 and @pd<="20030213"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/07/30 20:18		

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6	
7	